

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DAVID J. BAIN, ET AL.	)	
		)	Group Art Unit: 2836
Serial No.:	10/710,653	)	
		)	
Filed:	July 27, 2004	)	Examiner: Roman, L.
		)	
For:	PRESSURE ASSISTED WAFER	)	
	HOLDING APPARATUS AND	)	Confirmation No.: 4652
	CONTROL METHOD	)	

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE

Applicants request amendment to this application under 37 CFR § 1.312.